

Electronic Acknowledgement Receipt

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Application Number:	09605293
International Application Number:	
Confirmation Number:	5927
Title of Invention:	METHOD FOR CONTROLLING THE MORPHOLOGY OF DEPOSITED SILICON ON A SILICON DIOXIDE SUBSTRATE AND SEMICONDUCTOR DEVICES INCORPORATING SUCH DEPOSITED SILICON
First Named Inventor/Applicant Name:	DAVID L. CHAPEK
Customer Number:	23368
Filer:	Susan M. Luna/Beth Bane
Filer Authorized By:	Susan M. Luna
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File Listing:

Document Number	Document Description	File Name	File Size(Bytes)/ Message Digest	Multi Part /.zip	Pages (if appl.)
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1	Appeal Brief Filed	MIO0037VA_Appeal_Brief_with _Appendix.pdf	737378 <small>bf12195f60cbb3d6d48002f7656519752d6 fafa3</small>	no	39
Warnings:					
Information:					
2	Fee Worksheet (PTO-06)	fee-info.pdf	30619 <small>98e3d41559ed3ca9122260a056e40d2e8f a6d9</small>	no	2
Warnings:					
Information:					
Total Files Size (in bytes):			767997		
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